Electronic Patent Application Fee Transmittal							
Application Number:	10645665						
Filing Date:	22-Aug-2003						
Title of Invention:	Multiple frequency plasma etch reactor processor method and apparatus						
First Named Inventor/Applicant Name:	Raj Dhindsa						
Filer:	Allan M. Lowe						
Attorney Docket Number:	2328-062						
Filed as Large Entity							
Utility Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
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Extension-of-Time:							

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Submission- Information Disclosure Stmt	1806	1	180	180
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